

## Beam commissioning of the high intensity proton source developed at INFN-LNS for ESS

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Istituto Nazionale di Fisica Nucleare Laboratori Nazionali del Sud



17th International Conference on Ion Sources

October 15-20 2017

CERN - CICG - Geneva



#### **Italian In-Kind Contribution:**

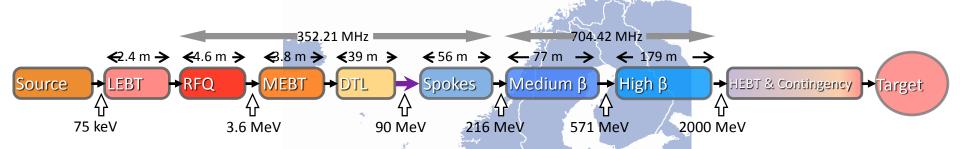
Proton Source, LEBT INFN-LNS

DTL INFN-LNL

T-REX, VESPA CNR

RF systems, Magnets&PS, diagnostics Elettra





#### Partners for proton source and LEBT:

INFN-LNS WP leader, Overall design, Construction, Commissioning, Installation

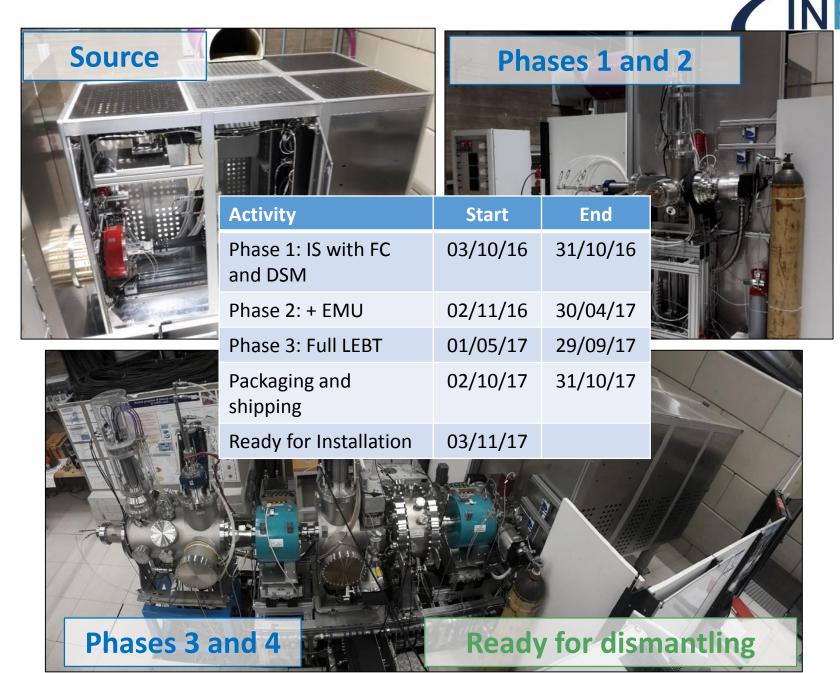
Vacuum, Controls, Beam diagnostics

CEA Controls, Beam diagnostics

**ESS** 



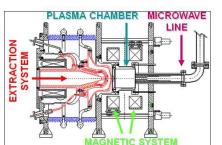
### Ion Source and LEBT



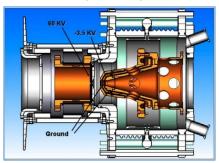
### **INFN-LNS** background



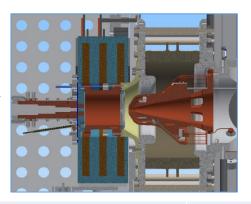
**TRIPS (2001)** 



**VIS (2008)** 



**PS-ESS (2016)** 



Performance	Value
Beam energy	80 Kev
Proton beam current	55 mA
Proton fraction	≈80%
RF frequency	2.45 GHz
RF power	Up to 1 kW
Axial magnetic field	875-1000 G
Duty factor	100 % (DC)
Extraction aperture	6 mm
Reliability	99.8% @ 35 mA
Transverse emittance (σ)	0.07 pi.mm.mrad
	@ 35 mA
Start-up after maintenance	32 hours

+ 25%

from dc to pulsed

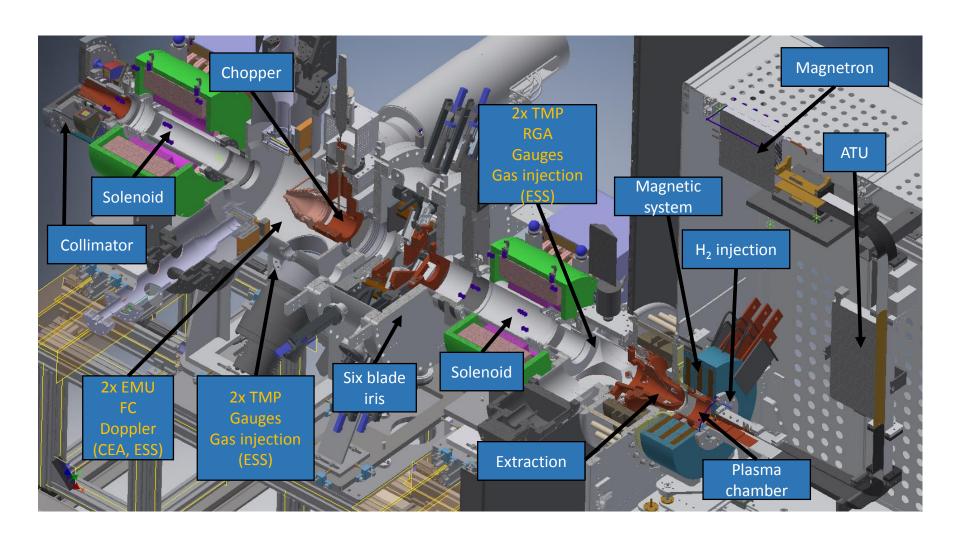
High stability
Low emittance

Requirement	Value		
Beam energy	75 ± 5 keV		
Energy adjustment	± 0.01 keV		
Total beam current	> 90 mA		
Proton beam current	74 mA		
Proton beam current range	6.7 - 74 mA		
Resolution	1.6 mA		
Proton fraction	> 75%		
Pulse length	6 ms		
Pulse flat top	3 ms		
Repetition rate	14 Hz		
Pulse to pulse stability	± 3.5 %		
Flat top stability	± 2 %		
Transverse emittance (99%)	1.8 pi.mm.mrad		
Beam divergence (99%)	< 80 mrad		
Start-up after maintenance	< 32 hours		

Easy maintenance ---

## Proton Source and LEBT at INFN-LNS INFN

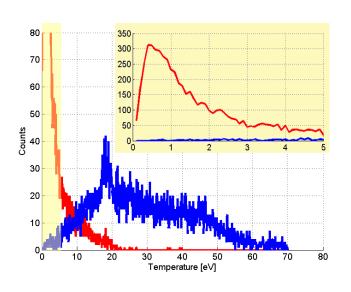




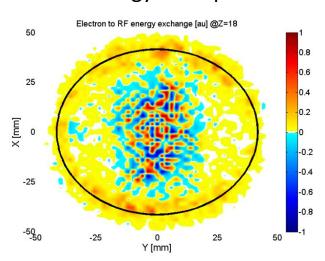
### Plasma modeling



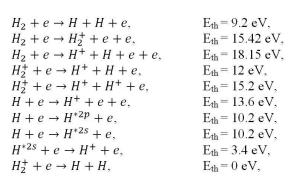
#### **Electron Energy Distribution Function**



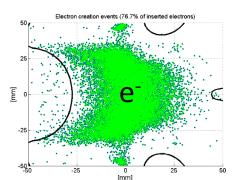
#### RF energy adsorption

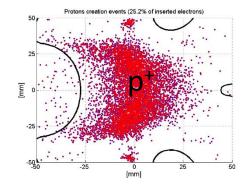


### Ion formation



### Generation maps

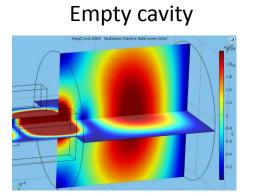




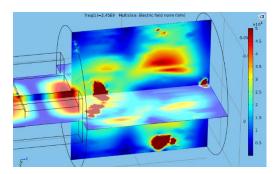
### Microwave to plasma coupling



3D full wave e-m simulation in presence of the electron plasma density and strong magnetic field has driven the design of the matching transformer

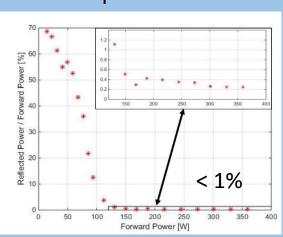


Cold tensor plasma approximation

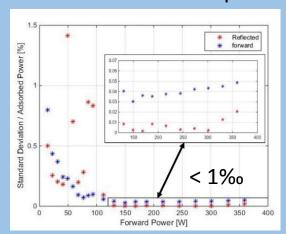


G. Torrisi et al. "Full-wave FEM simulations of electromagnetic waves in strongly magnetized non-homogeneous plasma", JEWA 2014 vol. 20, no. 9, 1085-1099

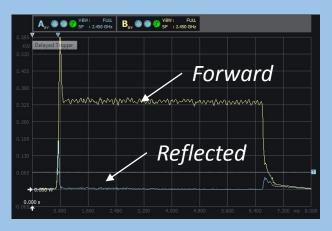
## Low measured reflected power



High measured stability of forward and reflected power



Measured forward and reflected pulsed power



G. Torrisi et al. "Microwave injection and coupling optimization in ECR and MDIS ion sources", Proc. of IPAC'17

### Beam extraction system



#### Axcel 2D beam input parameters:

Some simulation parameters:

Mesh =  $1096 \times 1424$ 

Ip = 10

N°particles = 21920

kTe = 15 eV

kTi = 0.25 eV

pot. Plasma = 20 V

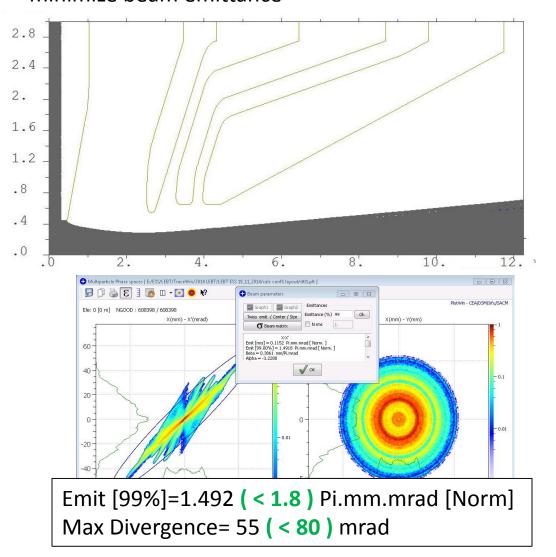
1 tot = 0.0925 A

I protoni = 0.074 A

1 H2 = 0.0185 A

To increase flexibility an interchangeable geometry was designed and different type of electrodes were manufactured

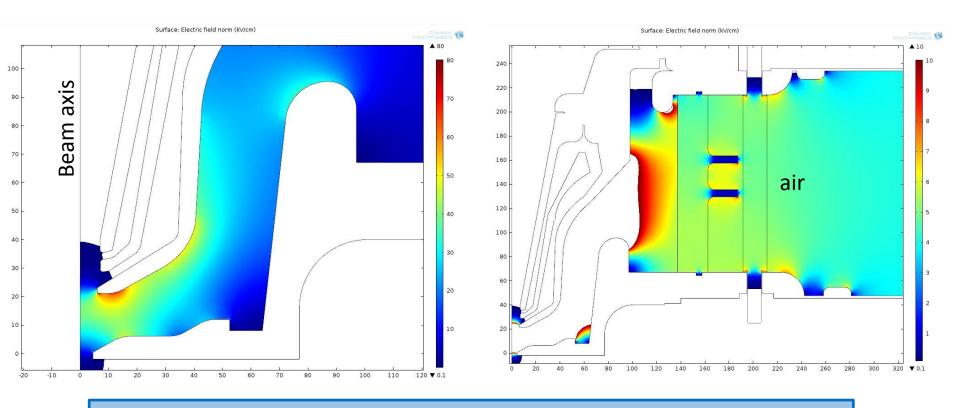
Simulations to optimized for larger current and minimize beam emittance



### Extraction column design



- Minimization off-axis electric field
- Electric field mimimazion at triple point (< 6.4 kV/cm)</li>
- X Ray protection
- Single alumina to minimize the electric field on the external surface (< 6.6 kV/cm)</li>



State-of-art sparks immunity during beam operation at 75 kV. Extraction column tested up to 90 kV.

# Increase electronics strength against discharge



Wide use of optical fibers

Shielded sub-rack on the HV platform







Grounding grid

FC voltage protection



Shielded sub-rack at ground

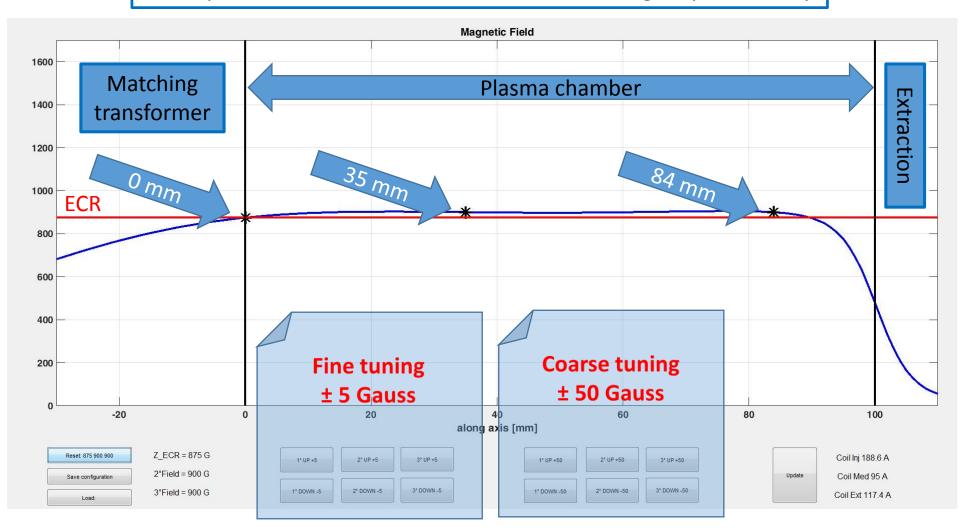




## Magnetic system control interface INFN

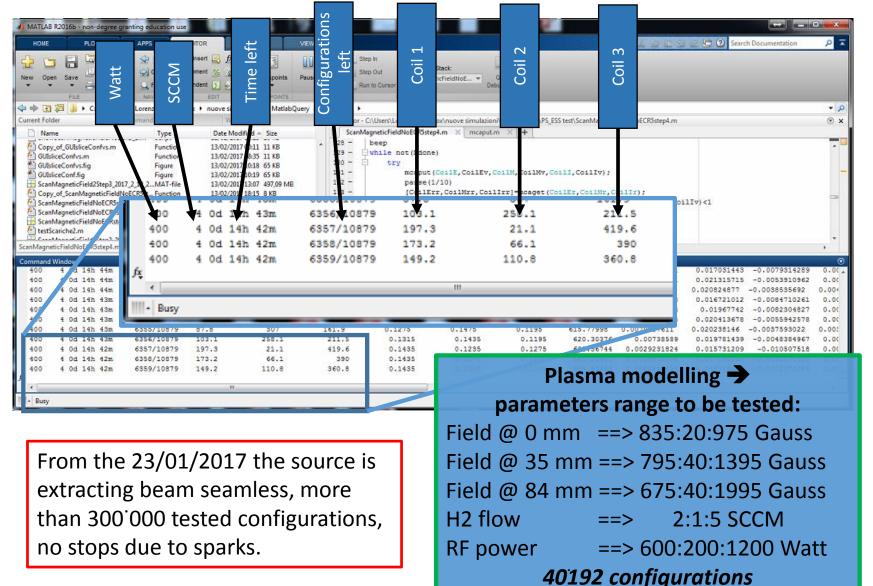


Very high magnetic flexibility required a dedicated interface developed at INFN that enable direct control and high reproducibility



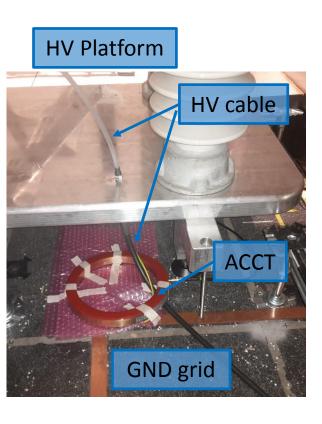
### Semi-automatic characterization tool

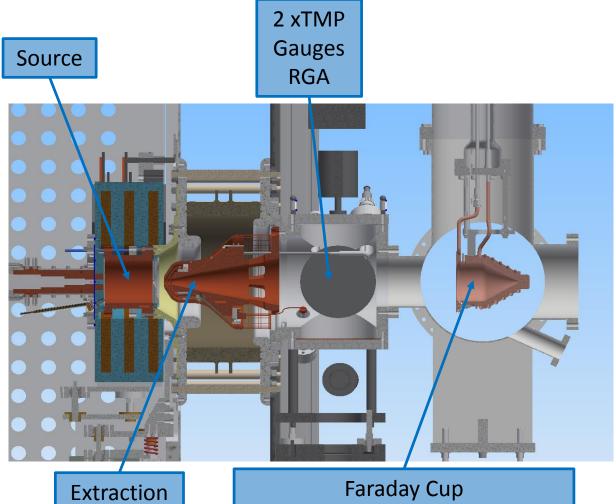




## Commissioning setup phases 1 and 2





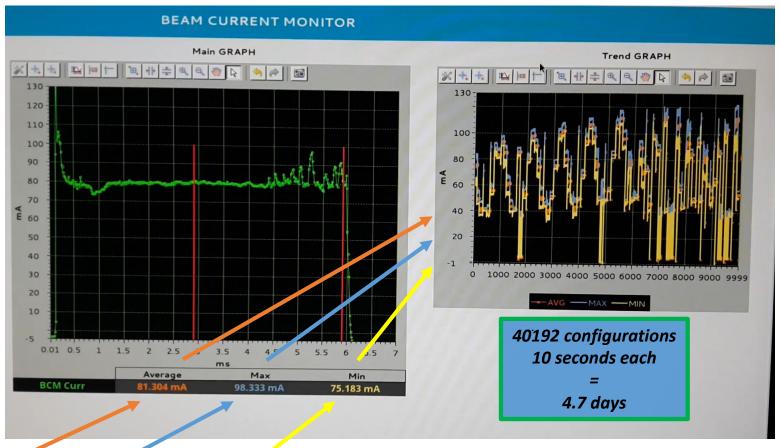


**Emittance Measurement Unit** 

Doppler Shift Measurement Unit

### Semi-automatic characterization



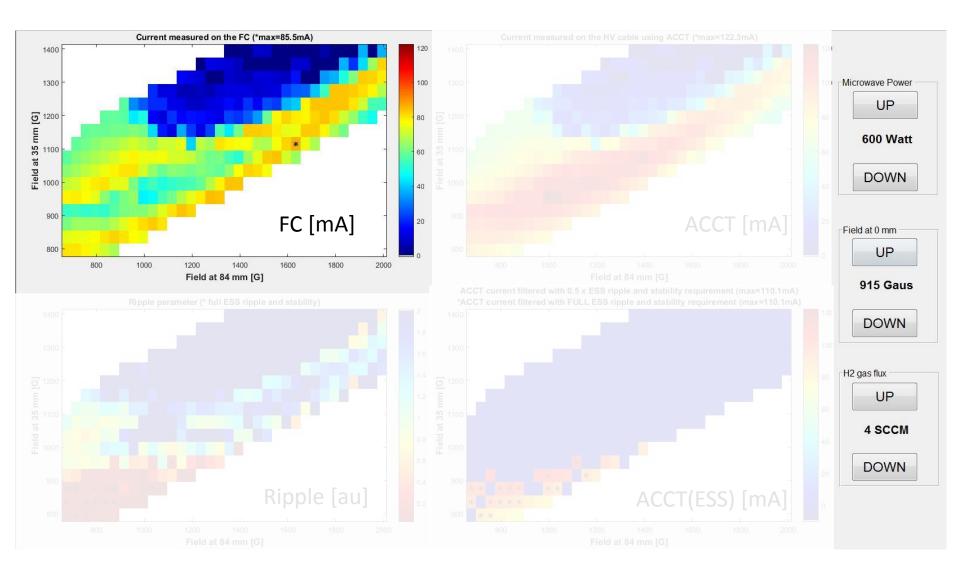


In the graphical interface: average, maximum and minimum are evaluated and the trend showed for the beam pulse between 2.9 ms and 5.9 ms.

In the semi-automatic characterization code 26 parameters and two wave forms (@1Ms/s) are saved for each pulse produced at nominal repletion rate of 14Hz.

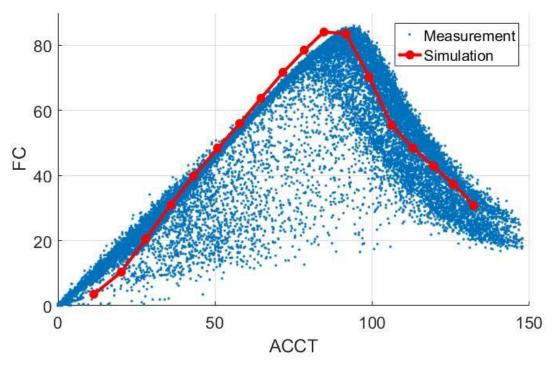
# Data analysis of thousands of different configurations





## Fraction of beam current collected INFN the Faraday Cup





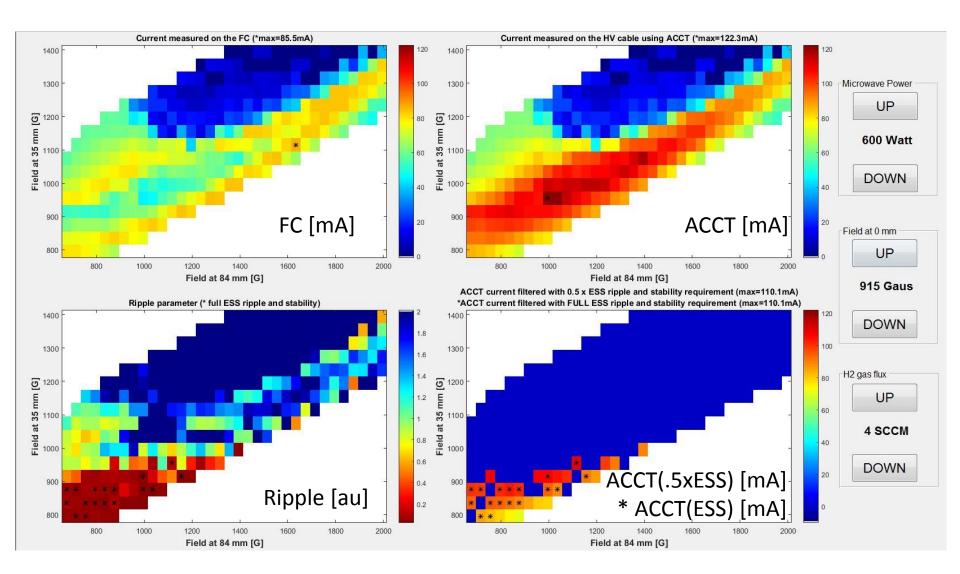
Courtesy of O. Midttun (*University of Bergen*)

Increasing the plasma density increase the meniscus concavity and the divergence of the extracted beam.

**Simulation done with IBSimu** shows good agreement with experimental data.

# Data analysis of thousands of different configurations

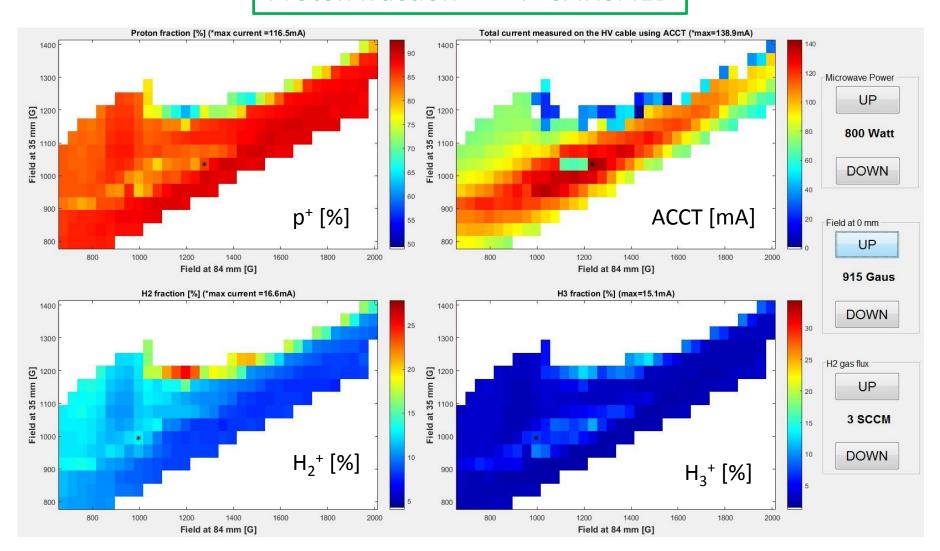




## Doppler shift measurement beam characterization



Proton fraction > 75% SATISFIED



# ESS stable configurations versus injected H<sub>2</sub> gas flux and microwave power



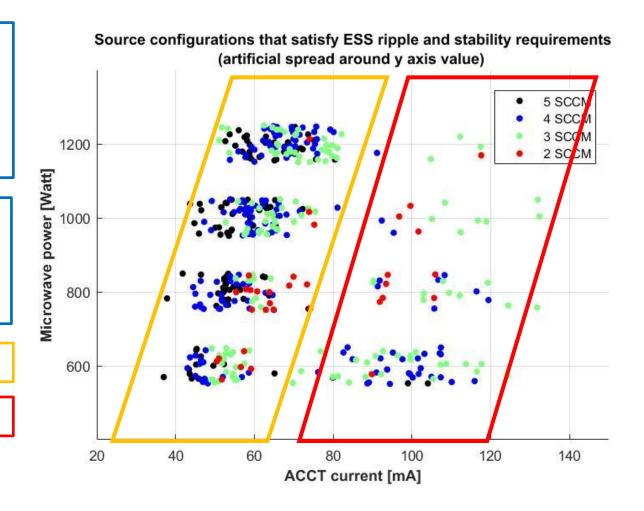
Total current = 100 mA SATISFIED

Increasing the injected microwave power increase the energy transfer and consequently the plasma density

Each point is a large operative range (20 Gauss x 40 Gauss x 40 Gauss x 1 SCCM x 200 Watt)

Lower current (2-5 sccm)

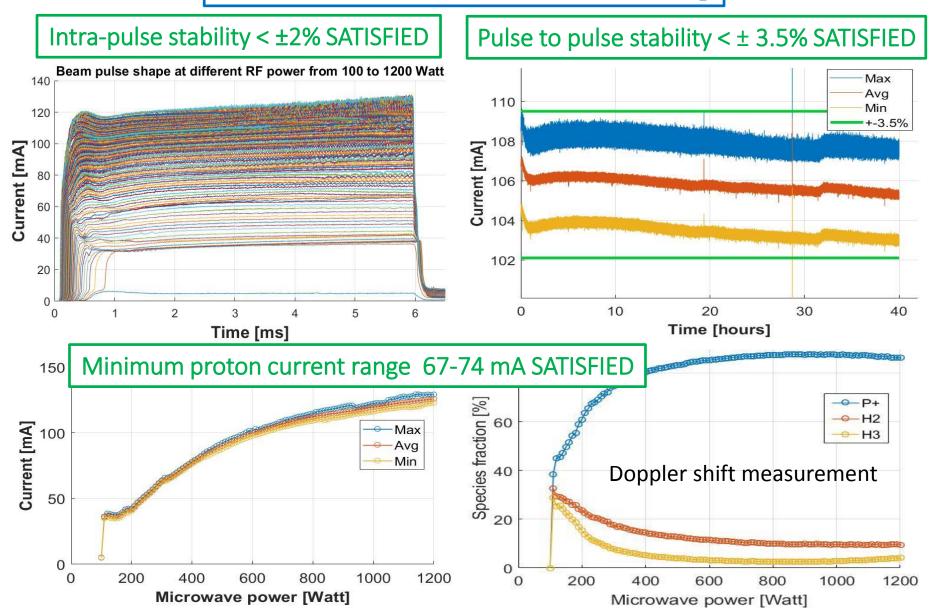
High current (2-4 sccm)



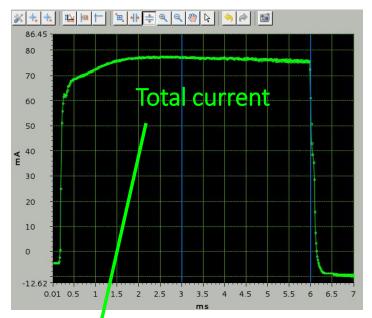
### ESS nominal configuration

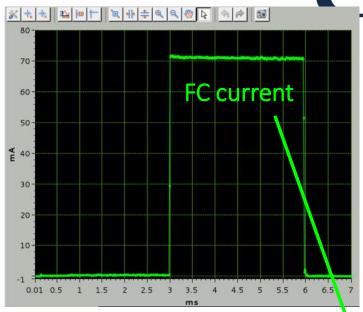


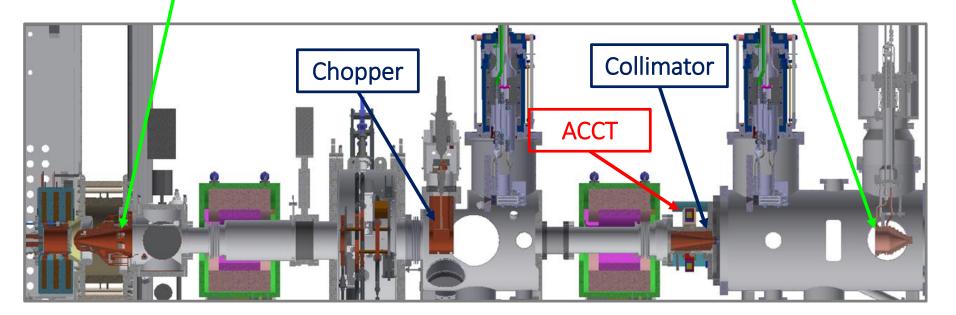
109 A coil1; 67 A coil2; 228 A coil3; 3 SCCM H<sub>2</sub>



### Chopping performaces



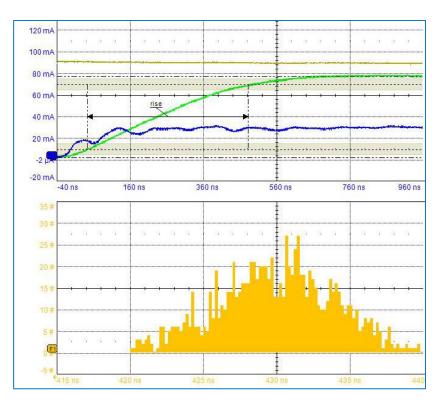




### Chopping performaces



Rise time: 430ns Fall time: 519 ns



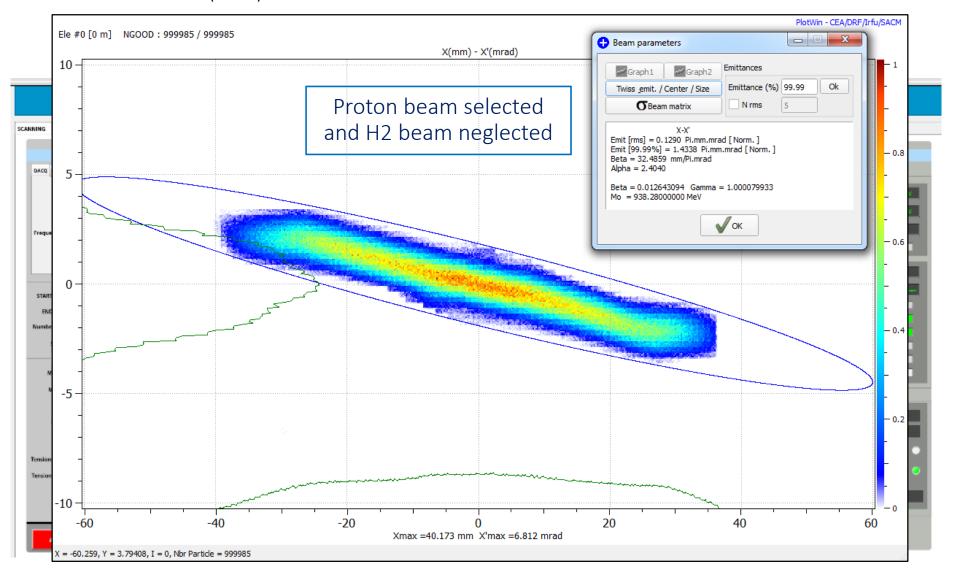


Beam pulse shape measured with the ACCT located at the end of the LEBT

### Beam emittance at the center of the LEBT

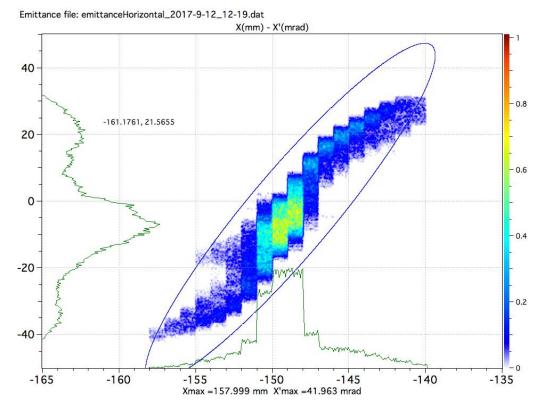


A parallel beam is obtained between the two solenoids Emittance (99%):  $1.43 \pi.mm.mrad$ 



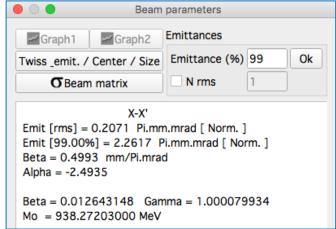
### Beam emittance at RFQ location





Transverse emittance **SATISFIED** Emit [rms] < 0.25 Pi.mm.mrad Emit [99%] < 2.25 Pi.mm.mrad Emittance measured after 100 mm of the RFQ beam lattice interface.

Back tracing simulation under going to evaluate twiss parameters at LEBT-RFQ beam lattice interface

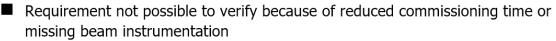


Beam extraction and Transport simulations in O. Midttun et al., T7\_We\_24

### Site Acceptance Review

	Name	
Authors	Øystein Midttun	
	Lorenzo Neri	
	Cyrille Thomas	

- Requirement achieved
- Requirement not achieved





### ION SOURCE PERFORMANCE AT THE END OF COMMISSIONING PHASE 2

### ION SOURCE AND LEBT PERFORMANCE AT THE END OF COMMISSIONING PHASE 4

Requirement	Value	Status	Requirement	Value	Status
Nominal beam current	74 mA	$\overline{\checkmark}$	Nominal beam current	70 mA	✓
Maximum beam current	> 90 mA		Transmission	> 95 %	$\checkmark$
Proton beam current range	67 – 74 mA		Beam current range	6 – 70 mA	✓
Proton fraction	> 75 %	✓	Beam current precision	1 mA	✓
Pulse length	6 ms	✓	Vacuum pressure	< 6e-5 mbar	✓
Flat top stability	± 2 %		Beam pulse flat-top length	0.05 - 2.86 ms	✓
Pulse to pulse stability	± 3.5 %	✓	Beam pulse rise/fall time	< 1 µs	✓
Beam energy	75 keV	✓	Transverse emittance (99%)	1.25 π.mm.mrad	✓
Beam energy fluctuation	± 0.01 keV		Twiss parameter α	1.02 ± 20 %	•
Transverse emittance (99%)	1.8 π.mm.mrad	<b>,</b>	Twiss parameter β	1.02 ± 20 %	/,=
Start-up after maintenance	< 32 hours	☑		/	

Stable EMU was not provided in time

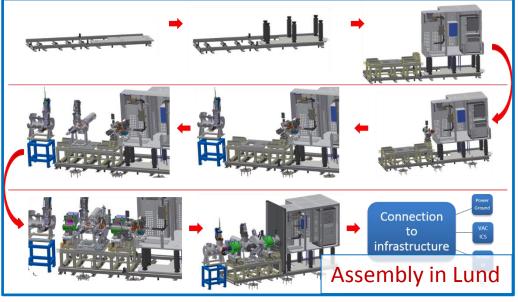
Back tracing simulation under going

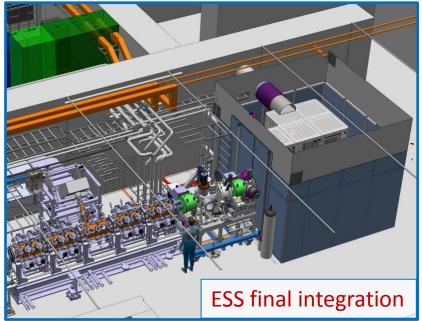
## Ready for ....





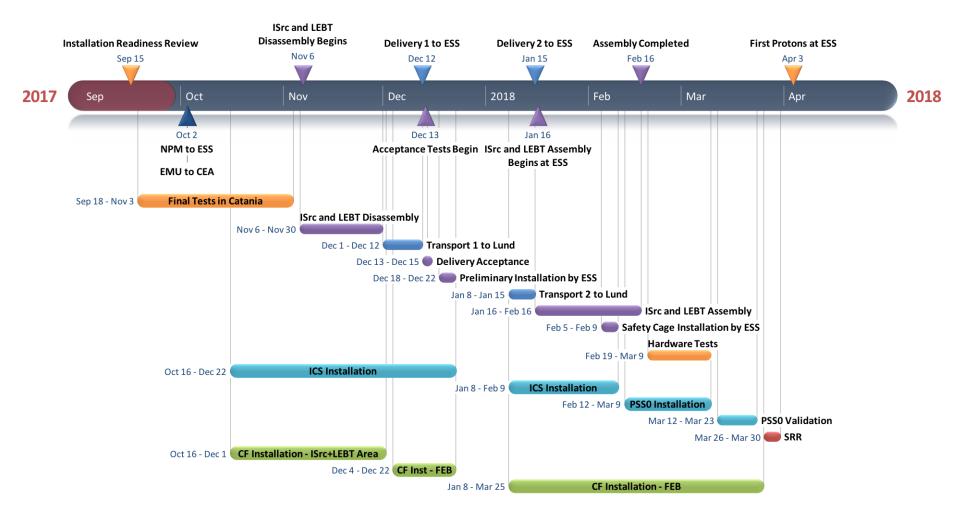






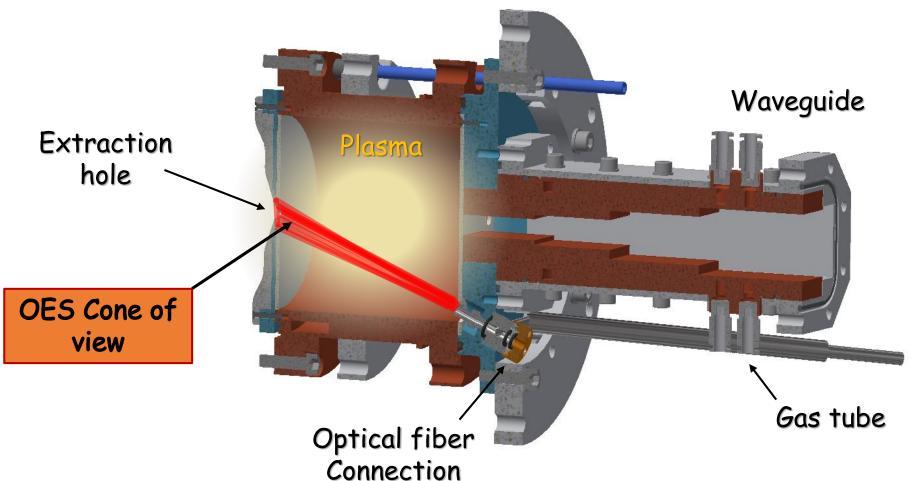
### Time line





### **OES** measurements



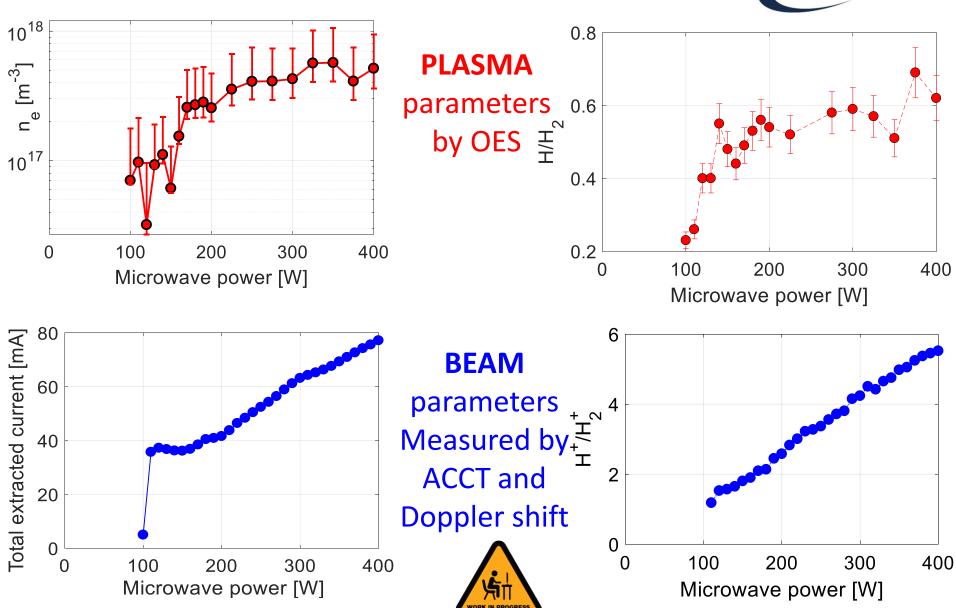


The Optical fiber is connected to the gas tube, via a quartz window and an adapter;

OES cone of view intercepts the plasma extraction region;

### From plasma to beam parameters,







## Conclusion & Perspectives

- The source works flawless since beginning of the year, some minor troubles typical of the commissioning phase have been met and solved.
- The source performance fully satisfy the ESS requirements
- Fast characterization procedure and data analysis have been the key points to speed up the commissioning phases, exploring source performance in a wide operational range
- First documentation has been provided to ESS (Drawings, Diagrams, FAT, ...)
- Second source procurement ongoing

## Thanks for your attention INFN



### Comments are welcome

Thanks to all INFN-LNS staff to valuable support provided during all the phases of the project.

The collaboration with ESS and CEA was intense, profitable, always solution oriented.



17th International Conference on Ion Sources

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CERN - CICG - Geneva

#### ECRIS 2018 23<sup>rd</sup> International Workshop on ECR ion sources



10-14 September 2018 Catania, Diocesan Museum





http://ecris18.lns.infn.it

STAY TUNED!